PATENT



IN THE UNITED STATES PATENT **AND TRADEMARK OFFICE**

Applicant: Hyug-Jin Kwon

Serial No.: 10/615,062

Filed:

July 8, 2003

Title:

BATCH TYPE ATOMIC LAYER

DEPOSITION APPARATUS AND IN-SITU CLEANING **METHOD THEREOF**

Group Art Unit:

1763

Examiner: Sylvia MacArthur

Attorney Docket No.: 29926/39496

I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on September 15, 2005.

Sandip H. Patel (Reg. No. 43,848)

Attorney for Applicant

AMENDMENT "A" AND RESPONSE TO OFFICIAL ACTION

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

In response to the non-final official action dated June 15, 2005, please amend the above-identified patent application as set forth herein.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.